

AF/IFW



**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2811**

PATENT
Customer No. 22,852
Attorney Docket No. 4329.3196

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Takamasa USUI)	Group Art Unit: 2811
)	
Application No.: 10/734,106)	Examiner: Stephen Ho Yin Loke
)	
Filed: December 15, 2003)	Confirmation No.: 4860
)	
For: SEMICONDUCTOR DEVICE)	Mail Stop AF
USING INSULATING FILM OF)	
LOW DIELECTRIC CONSTANT)	
AS INTERLAYER INSULATING)	
FILM)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed July 13, 2005, the period for response to which extends through October 13, 2005, and pursuant to 37 C.F.R. § 1.116, Applicant proposes that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment sections of this paper.